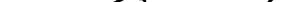


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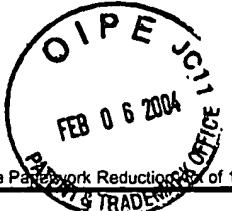
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Attorney Docket Number																	
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Examiner Signature	 	Date Considered	3/18/07
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<p>Substitute for form 1449B/140 INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(use as many sheets as necessary)</i></p>		Complete if Known	
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		Art Unit	Unknown
		Examiner Name	Unknown
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		Attorney Docket Number	

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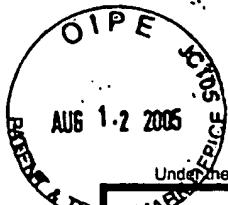
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U.S. PATENT DOCUMENTS

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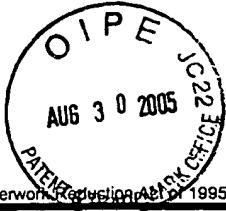
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Application Number	10/720,035
Filing Date	November 21, 2003
First Named Inventor	Tsang, Francis
Group Art Unit	3663
Examiner Name	Unknown

Sheet 1 of 4

Attorney Docket No: 2408.001US1

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Examiner Initials*	Cite No. 1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT <i>(Use as many sheets as necessary)</i>		Complete if Known Application Number 10/720,035 Filing Date November 21, 2003 First Named Inventor Tsang, Francis Group Art Unit 3663 Examiner Name Unknown	
Sheet 2 of 4		Attorney Docket No: 2408.001US1	

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		Application Number	10/720,035
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<p>Substitute for form 1449A/PTO INFORMATION DISCLOSURE STATEMENT BY APPLICANT <small>(Use as many sheets as necessary)</small> </p>		<p>Complete if Known</p>	
		Application Number	10/720,035
		Filing Date	November 21, 2003
		First Named Inventor	Tsang, Francis
		Group Art Unit	3663
		Examiner Name	Unknown
Sheet 1 of 1		Attorney Docket No: 2408.001US1	

OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS			
Examiner Initials	Cite No	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T
<i>[Signature]</i>		ENDERBY, J. E., "Liquid semiconductors", Rep. Prog. Phys., 53, (1990), 85-179	

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DATE CONSIDERED

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Substitute Disclosure Statement Form PTO-1449
 Examiner: initial if reference considered, whether or not citation is in conformance with MPEP 609. Cross out through citation if not in conformance and not considered. Include copy of this form with rest communicated to applicant. (Applicant's unique citation designator number (optional)) Applicant is to place a check mark here if English language Translation is attached

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